

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

**APPLICANT:** Fitzgerald

**SERIAL NUMBER:** Not yet assigned **ART UNIT:** Not yet assigned

**FILING DATE:** Herewith **EXAMINER:** Not yet assigned

**TITLE:** Controlling Threading Dislocation Densities in Ge on Si Using Graded  
GeSi Layers and Planarization

**Mail Stop PATENT APPLICATION**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**Particulars of Prior Application:**

Serial No.: 09/611,024

Filed: July 6, 2000

Group No.: 2826

Examiner: Minhloan Tran

**PRELIMINARY AMENDMENT**

After assigning a filing date and serial number to the above-identified continuation application, please amend this continuation application indicated below.

**Amendment to the Specification** begins on page 2 of this paper.

**Applicant's Remarks** begin on page 3 of this paper.